



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## \*BIBDATASHEET\*

CONFIRMATION NO. 6696

Bib Data Sheet

SERIAL NUMBER 09/715,000	FILING DATE 11/20/2000  RULE	CLASS 438	GROUP ART UNIT 2825	ATTORNEY DOCKET NO. PF-2695
-----------------------------	---------------------------------------	--------------	------------------------	-----------------------------------

## APPLICANTS

Hidemitsu Aoki, Tokyo, JAPAN;

Hiroaki Tomimori, Tokyo, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

NONE, CAL

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

YES, CAL

JAPAN 11-329324 11/19/1999

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/26/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 56	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged  Examiner's Signature: <i>[Signature]</i> Initials: <i>IA</i>				

## ADDRESS

000466  
 YOUNG & THOMPSON  
 745 SOUTH 23RD STREET  
 2ND FLOOR  
 ARLINGTON, VA  
 22202

## TITLE

Improved semiconductor wafer surface and method of treating a semiconductor wafer surface

FILING FEE  RECEIVED 1438	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____
------------------------------------	---	--